Controlling the Metal to Semiconductor Transition of MoS$_2$ and WS$_2$ in Solution

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ABSTRACT: Lithiation-exfoliation produces single to few-layered MoS$_2$ and WS$_2$ sheets dispersible in water. However, the process transforms them from the pristine semiconducting 2H phase to a distorted metallic phase. Recovery of the semiconducting properties typically involves heating of the chemically exfoliated sheets at elevated temperatures. Therefore, it has been largely limited to sheets deposited on solid substrates. Here, we report the dispersion of chemically exfoliated MoS$_2$ sheets in high boiling point organic solvents enabled by surface functionalization and the controllable recovery of their semiconducting properties directly in solution. This process connects the scalability of chemical exfoliation with the simplicity of solution processing, ultimately enabling a facile method for tuning the metal to semiconductor transitions of MoS$_2$ and WS$_2$ within a liquid medium.

However, because drying from solution limits the processability of the exfoliated materials, there is thus desire to control the phase composition of the sheets directly in solution. In doing so, it would enable broader applicability for scalable processing and device integration.

To accomplish this, it would be ideal to anneal sheets in inert, high boiling point organic solvents that can withstand elevated temperatures without degrading the exfoliated sheets, such as octadecene or o-dichlorobenzene (ODCB). However, this is hindered by the poor dispersibility of chemically exfoliated sheets in organic solvents due to their highly negatively charged surface. Moreover, since annealing restores the hydrophobic semiconducting phase, annealing in polar solvents induces flocculation. Furthermore, as exfoliated monolayers are prone to oxidation, heating in even partially oxygenated environments, such as in most polar solvents, can quickly degrade the material.

To solve this problem, we present a one-step surface functionalization of chemically exfoliated MoS$_2$ to enable their transfer from water to diverse classes of inert organic solvents. Heating the sheets in inert, high boiling point solvents makes it possible to tune their phase compositions and control the metal-to-semiconductor transition with minimal risk of oxygenation. Moreover, the resultant sheets maintain their solution processability and can be assembled into pliable and transferable free-standing films. Our method is potentially extendable to other MX$_2$ materials of interest, such as WS$_2$. Dispersity in organic solvents and in situ property tuning should significantly broaden the capability of solution processing of these two-dimensional sheets for potential device applications.

To exfoliate MoS$_2$ with Li intercalation into water, we followed previously described methods with slight modifications (Supporting Information). The chemically exfoliated sheets were then transferred from water into inert nonpolar solvent via a biphasic reaction by using a weakly cationic amphiphile, oleylamine, dissolved in excess in the nonpolar solvent. The oleylamine’s nitrogen terminus allows for electrostatic binding to the sheets. Upon sufficient coverage, the ligand forms a hydrophobic coating, which enables phase transfer.
As seen in Figure 1b, this process transfers and disperses chemically exfoliated MoS$_2$ into most nonpolar organic solvents. For the purpose of annealing, inert high boiling point solvents such as ODCB (bp 180 °C) and octadecene (bp 315 °C) were most useful. For most transfers, the MoS$_2$ concentration plateaus at 0.5 mg/mL within the organic solvent. On the basis of thermogravimetric analysis, the binding ratio of MoS$_2$ to ligand is 1:3; the remainder of ligands is kept in solution as excess (Figure S1). Care should be taken at this point to thoroughly purge the air with N$_2$ or Ar. Following the purge, solutions were heated to near reflux for 4 h. The annealed samples were then collected with centrifugation and redispersed in hexane containing 2.5% oleylamine. As seen in Figure 1c, before annealing, Mo atoms on the basal plane exhibited patches of clustered Mo, with short (2.8 ± 0.3 Å) and long (3.8 ± 0.3 Å) periodicities in Mo–Mo distance. This in turn gives rise to zigzag-like patterns and a superlattice formation. In the literature, this phase is alternatively dubbed the 1T$'$ or 1T and is a p-type conductor. After annealing in octadecene (300 °C), the superlattice disappears, and a typical Mo lattice spacing of 3.15 Å can be seen (Figure 1d,e). This is indicative of the metal to semiconductor transition to the 2H phase. It should be noted that after annealing the material maintains a sheet-like morphology (Figure 1f).

Previously, a correlation between X-ray photoelectron spectra (XPS) and the metal to semiconductor transition was shown, using the changing bonding states of Mo and S. We similarly corroborate TEM results showing the phase transition with XPS, following annealing at different solution temperatures (Figure 2a). For this analysis, we calibrated our system using the carbon sp$^2$ C–C peak (284.6 eV) and then measured 2H peak positions using a single crystal MoS$_2$ reference. These resulting reference spectra, with Mo 3d$^{5/2}$ at 229.1 eV and its doublet, Mo 3d$^{3/2}$, at 3.15 eV higher, then served as references for the 2H in the remaining samples. Peak positions for the 1T$'$ phase was obtained using freshly exfoliated samples, which showed additional, non-2H peaks at 228.1 eV (1T$'$ Mo 3d$^{5/2}$) and 231.3 eV (1T$'$ Mo 3d$^{3/2}$). Phase percentages were then calculated by peak area ratios of Mo 3d$^{5/2}$ (Mo 3d$^{3/2}$ peak heights were constrained based on 3d$^{5/2}$ and thus not used in analysis). The same analysis was extended to the complementary sulfur spectra, with S 2H 2p$^{3/2}$ peak at 161.9 eV and 1T$'$ 2p$^{3/2}$ peak at

Figure 1. (a) Phase transfer of chemically exfoliated MoS$_2$ from water into inert high boiling point, organic solvents. (b) MoS$_2$ in organic solvents with decreasing polarity, from chloroform (CHCl$_3$), dichloromethane (DCM), ODCB, ethyl acetate (EA), and toluene to octadecene and hexane (C$_6$H$_{14}$). Colorless portion is water. (c) High-resolution STEM of MoS$_2$ after exfoliation. (d) STEM of MoS$_2$ after annealing. Images were false colored for clarity. (e) Diffraction pattern after annealing. (f) Morphology of MoS$_2$ sheets after annealing.

Figure 2. (a) XPS spectra of MoS$_2$ annealed at increasing solution temperatures, for 4 h each. (b) Corresponding phase percentage from XPS spectra and (c) Raman spectra.
160.9 eV, yielding corroborating results (for a detailed fitting procedure and summary, please see Tables S1 and S2).

A summary of this analysis can be seen in Figure 2b, with peak fittings for the metallic 1T being most prominent in freshly exfoliated, room temperature samples (69.0 ± 2.1%). With increasing solution temperature, 1T percentages began to decrease, and 2H percentage began to increase. First, after heating to 75 °C, the 2H phase fraction was raised from 23.9 ± 7.8% to 32.3 ± 0.6%. Further, at a 150 °C, 2H fractions reached 78.3 ± 6.2%, and at 300 °C, the 2H phase was 89.2 ± 2.7%. As shown in Figure 2b, the major metal to semiconductor (1T → 2H) transitions occurred between 75 and 150 °C, which is within the range of literature reports.15,22,27

Nonetheless, high temperature processing has a tendency to oxidize MoS2. For example, Mo spectra of MoS2 annealed in ethylene glycols will produce prominent oxidation peaks at 235 to 236 eV (Figure S2). However, spectra in Figure 2a showed minimal oxidative peaks indicating the inert organic solvents were effective in averting oxidative degradation. This is confirmed with an analysis of the oxidative peaks in the Mo spectra, which show minimal difference between processed samples and controls (Table S3).

The phase transition was further corroborated using Raman spectroscopy. Previously, it was reported that with chemical exfoliation, 2H Raman signatures are attenuated.32,33 Correspondingly, we observed restoration of 2H signatures with increasing solution temperature (Figure 2c). In particular, E_{1g} at 383.2 cm$^{-1}$ and A_{1g} at 405.1 cm$^{-1}$ become increasingly prominent with solution annealing. This corroborates the TEM and XPS results for the metal to semiconductor transition. Further, we observe that the ratio of E_{1g}/E_{2g} in-plane vibration mode to A_{1g} out-of-plane vibration mode, were maintained near 0.8. As the ratio is an indicator of grains size distribution, 0.8 indicates small, submicron grain sizes.37 This is not surprising, as chemically exfoliated sheets are typically submicron. Further, the result is comparable to the synthetic precursors used here, and those seen on some CVD grown MoS2 films.34

To assemble free-standing films for device measurements, MoS2 solution was filtered over aluminum oxide membranes. In general, we found that films were easily transferable to arbitrary substrates (Figure 3a). Similar to individual sheets (Figure S3), the assembled MoS2 films displayed increased photoluminescence in correspondence to raised solution annealing temperature (Figure 3b). It is likely that films with a predominance of the metallic 1T’ induce photoquenching within the specimen.35 As samples were annealed, the metallic 1T’ phase transitioned to the semiconducting 2H phase, thus reducing propensity for quenching and giving rise to increased photoluminescence. Corresponding to the photoluminescence measurements, four-probe measurements of films yielded corroborative evidence of a conductor to semiconductor transition in relation to increased 2H fractions. On the whole, the resistance undergoes a 5 order of magnitude transition in correspondence to the solution heating temperature (Figure 3e). Furthermore, resistance scaled in proportion to 2H fractions (Figure 3f). To cross validate the metal–semiconductor transition, a 300 °C film was configured as a transistor using a polyelectrolyte gate (Figure S4). Here, the film exhibited p-type conductivity, which is consistent with previous reports using the chemical exfoliation process.27 Additionally, an I_{off}/I_{on} ratio was observed with the annealed specimens. Comparatively, the predominantly 1T samples show no gate modulation, due to their conductive behavior.

Analogous experiments with chemically exfoliated WS2 yielded results similar to MoS2. As shown in Figure S5, the functionalization process transferred chemically exfoliated WS2 sheets from water into organic solvents. Further, XPS signatures from chemical exfoliation were removed after annealing in liquid. This again demonstrates an effective metal to semiconductor conversion in solution. As the ligand attachment process is governed by electrostatic charge, we suspect this method may be adopted toward other 2D materials that contain anionic charges on the basal plane, including MX2 materials that can be exfoliated with the assistance of Li intercalation.

In summary, we have described the transference of chemically exfoliated MX2 sheets from water into nonpolar organic solvents through surface functionalization, thus overcoming the incompatibility of chemically exfoliated sheets with inert organic solvents. Furthermore, by selecting inert organic solvents with appropriate boiling point, we can thermally anneal the sheets in liquid to enable a metal to semiconductor transition with minimal oxidative degradation. These can be assembled into macroscopic free-standing films and patterns and can be transferred onto secondary substrates or used as unsupported papers. This process synergistically integrates the scalability of chemical exfoliation with ease of solution processing, thereby enabling a facile method for tuning their metal to semiconductor transition in solution.

![Figure 3](image-url)

**Figure 3.** (a) MoS2 film transferred onto secondary substrate. (b) Photoluminescence evolution with solution temperature. (c,d) Cross-sectional profile of free-standing MoS2 film. (e) Sheet resistance of films processed at different solution temperatures. (f) Sheet resistance as a function of 2H.
■ ASSOCIATED CONTENT

Supporting Information
Experimental procedures and additional characterization data. This material is available free of charge via the Internet at http://pubs.acs.org.

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Notes
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